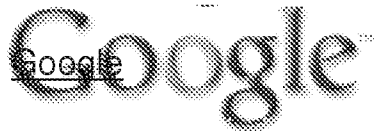


**Web** [Images](#) [Maps](#) [News](#) [Shopping](#) [Gmail](#) [more](#) ▼

[withersgs@gmail.com](mailto:withersgs@gmail.com) | [My Notebooks](#) | [My Account](#) | [Sign out](#)





[Advanced Search](#)  
[Preferences](#)



**Web**

Results **1 - 10** of about **1,060,000** for **nitrided metal silicide**. (0.31 seconds)

### Semiconductor device and method of manufacturing the same - US ...

a gate electrode formed on the gate dielectric film and including a **nitrided metal silicide** layer which is partially crystallized; and ...

[www.patentsstorm.us/patents/6982467-claims.html](http://www.patentsstorm.us/patents/6982467-claims.html) - 18k - [Cached](#) - [Similar pages](#) - [Note this](#)

### Encapsulated MOS transistor gate structures and methods for making ...

The method of claim 3, wherein forming the **metal** or **metal silicide** comprises forming a **nitrided metal**, **metal aluminum nitride**, or **metal silicon nitride** ...

[www.patentstorm.us/patents/7091119-claims.html](http://www.patentstorm.us/patents/7091119-claims.html) - 22k - [Cached](#) - [Similar pages](#) - [Note this](#)

[More results from www.patentstorm.us »](#)

### Silicon **nitride** ceramics containing a **metal silicide** phase ...

Disclosed is a sintered ceramic product comprising (a) 20-98 percent by weight silicon **nitride**, (b) 1-80 percent by weight of a **silicide** of iron, ...

[www.freepatentsonline.com/5023214.html](http://www.freepatentsonline.com/5023214.html) - 35k - [Cached](#) - [Similar pages](#) - [Note this](#)

### Semiconductor structure including **metal nitride** and **metal silicide** ...

The present invention relates to a semiconductor structure including **metal nitride** and **metal silicide**, where a **metal silicide** layer is formed upon an active ...

[www.freepatentsonline.com/6326668.html](http://www.freepatentsonline.com/6326668.html) - 61k - [Cached](#) - [Similar pages](#) - [Note this](#)

[More results from www.freepatentsonline.com »](#)

### Silicon **nitride-metal** joints: phase equilibria in the systems Si ...

argon. Ternary powder compacts were prepared by mixing and cold pressing binary **metal silicide** powder, and silicon **nitride** powder. The green compacts were ...

[www.springerlink.com/index/RJ16517376674753.pdf](http://www.springerlink.com/index/RJ16517376674753.pdf) - [Similar pages](#) - [Note this](#)

### (WO/1998/059366) **METAL AND METAL SILICIDE** NITRIDIZATION IN A HIGH ...

... of at least a portion of said layer of **metal** or **metal silicide** to produce a composition of **metal nitride** or **metal silicon nitride**, respectively. ...

[www.wipo.int/pctdb/en/wo.jsp?wo=1998059366&IA=WO1998059366&DISPLAY=CLAIMS](http://www.wipo.int/pctdb/en/wo.jsp?wo=1998059366&IA=WO1998059366&DISPLAY=CLAIMS) - 20k

- [Cached](#) - [Similar pages](#) - [Note this](#)

### (WO/2000/014780) SEMICONDUCTOR PROCESSING METHOD, SEMICONDUCTOR ...

A semiconductor processing method comprising: forming a **metal silicide** layer ... over the **metal silicide** layer; and forming a layer of silicon **nitride** over ...

[www.wipo.int/pctdb/en/wo.jsp?wo=2000014780&IA=WO2000014780&DISPLAY=CLAIMS](http://www.wipo.int/pctdb/en/wo.jsp?wo=2000014780&IA=WO2000014780&DISPLAY=CLAIMS) - 20k

- [Cached](#) - [Similar pages](#) - [Note this](#)

[More results from www.wipo.int »](#)

High-performance **metal/silicide** antifuse (for CMOS technology ...

Histogram of programmed resistance for **metal/silicide** anti-. fuses. The area of the antifuse is 0.8  $\mu\text{m}$  x 0.8  $\mu\text{m}$ ; the dielectric is. oxide/**nitride** stack of ...

ieeexplore.ieee.org/iel1/55/4973/00192798.pdf?tp=&isnumber=&arnumber=192798 - [Similar pages](#) - [Note this](#)

Preparation of sialon-transition **metal silicide** composites

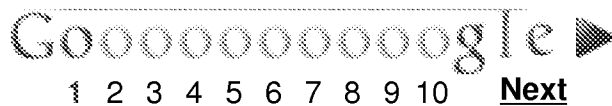
(1) Sialon-transition **metal silicides** composites with uni-. formmicrostructurecanbepreparedbyreactionsintering. of silicon **nitride** and transition **metal** ...

linkinghub.elsevier.com/retrieve/pii/S0955221904004546 - [Similar pages](#) - [Note this](#)

IngentaConnect Texture of transition-**metal** boride, **nitride**, and ...

Texture of transition-**metal** boride, **nitride**, and **silicide** films produced by ion deposition. Authors: Ignatenko, P.1; Goncharov, A.; Terpii, D. ...

www.ingentaconnect.com/content/maik/inma/2007/000000043/00000004/00004003 - [Similar pages](#) - [Note this](#)



nitrided metal silicide

Search

[Search within results](#) | [Language Tools](#) | [Search Tips](#) | [Dissatisfied? Help us improve](#) | [Try Google Experimental](#)

©2008 Google - [Google Home](#) - [Advertising Programs](#) - [Business Solutions](#) - [About Google](#)